

**Search Notes**

Application/Control No.

10/001,499

Examiner

Steven D. Maki

Applicant(s)/Patent under  
Reexamination

ZHOU ET AL.

Art Unit

1733

**SEARCHED**

| Class   | Subclass | Date     | Examiner   |
|---------|----------|----------|------------|
| 156     | 307.3    |          |            |
|         | 313      |          |            |
| 428     | 116      |          |            |
|         | 118      |          |            |
| 442     | 181      |          |            |
| 523     | 435      |          |            |
|         | 440      |          |            |
| updated | above    | 1/4/2006 | <i>SDM</i> |
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**INTERFERENCE SEARCHED**

| Class | Subclass | Date | Examiner |
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**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

|      | DATE     | EXMR       |
|------|----------|------------|
| none | 1/4/2006 | <i>SDM</i> |
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